PENNSTATE A MEMS



Clapping Wing Nano Air Vehicles Using Piezoelectric T-beam Actuators K. Mateti¹, H. K. R. Kommepalli², S. Tadigadapa¹, C. D. Rahn²



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Figure 1: Conceptual drawing of NAV (left) and fabricated device (right)

All four-winged 'X' type clapping designs however, use electromagnetic motors, gears, linkages and crank-rocker mechanisms, that are difficult to fabricate and have poor efficiency at the sub-millimeter scale.Piezoelectric actuators, however, are attractive because they have high power density, and high efficiency. This research presents the first piezoelectrically driven four winged clapping wing nano air vehicle.

Nano air vehicles are defined as having wingspans less than 7.5 cm and weighing less than 10 g. Flapping wing NAVs can provide superior indoor mobility for reconnaissance, search and rescue, and hazardous environment exploration. Clapping wing air vehicles are inspired by the Weis-Fogh clap and fling mechanism used by certain insects, where opposing wings almost touch during part of the flap cycle, spawning vortex structures that increase thrust.



Figure 2: Early prototype of a four winged clapping nano air vehicle

Figure 5: Schematic diagram stroke amplification mechanism, where δ_{ap} , k_{a} are the displacement, force, and

, n_{ϕ} the use photom photom, for the stiffness of the T-beam, g is the clearance between the two hinges, and $\theta=2\delta_{ay}(g)$, a key design parameter

Lift is proportional to tip

amplitude, and wing area.

The flapping resonance

frequency is maximized

designing the rotational

of the T-beam and gap

 $k_{tb} = \frac{6E_{PZT}I_{tb}}{L_{tb}^2(2L_{tb} + L_{pin})}$

 $f_s = \frac{1}{2\pi}g \sqrt{\frac{k_{tb}}{J_{wing_x}}}$

 $J_{wing_x} = \frac{m_r L_r^2}{12} + 2m_{eff} (\frac{L_s^2}{12} + L_{CG_y}^2)$

clearance

while maintaining a stroke

amplitude. This is tuned by

inertia of the wing, stiffness

velocity, wing stroke



Figure 6: Fabrication process for T-beam ictuators photolithography patterns bottom lectrode

(a)T-beams are fabricated from bulk 1mm thick PZT-5H (b) a high precision dicing saw machines the PZT (c) photolithography patterns bottom electrodes



Figure 9: End view of fabricated T-beams

Fabrication



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162.5 µm tungsten pins and 1 mm x 29 AWG medical syringes form revolute joints. These bond to Si extensions using silver epoxy which then bond to the T-beams using cyanoacrylate . Silver epoxy beads form load bearings which pull the NAV. Wings bond to the ends of the tungsten pins using two part epoxy.



Flexure hinges are created by spacing a 6 cm x 200 µm x 600 µm stainless steel wing support and 100 µm Al foil wing frame 150 µm apart on stretched 12.5 µm thick mylar sheets. Wings are cut and bond to the stroke amplification mechanism shown in figure 7.



Figure 3: Schematic of the flexure hinge, leading edge, and wing frame. L_{flex} , L_{ccir} , and t_{sc} are key design parameters for wing rotation

Wing rotation is crucial to produce lift. A flexure hinge n the wing allows passive wing rotation during the flap cycle. To ensure proper wing trajectory, the rotational nertia and stiffness of the flexure must be designed properly with respect to the flapping frequency.



Figure 4: Schematic diagram of the NAV model: (a) top view, and (b) cross-section of a T-beam actuator. Beam 4 is connected to beams 1 and 2 with hinges at b-b' and d-d' and beam 5 is hinged to T-beams 2 and 3 at d-d" and f-f". T-beam actuators bend upwards when an electric

Design

field is applied in the direction of poling. Optimized the small displacement of the T- $\frac{a \rho \bar{c}^2}{4} L_s$ beams are amplified by a stroke amplification mechanism. The flapping $\theta = 2 \tan^{-1}(\delta/g) \approx 2\delta/g$

where, δ is the T-beam displacement and, g is the clearance between hinges

Conclusion

A novel mechanism for producing clapping wing motions in a four winged NAV using piezoelectric T-beam actuators has been designed, fabricated and tested. Stroke amplitude of ~30° is obtained at 9Hz with 0.7 V/µm and 0.1 V/m DC bias. Flexure hinges on the wing allow ~30° of passive rotation during the flap cycle. The NAV produced 1.34 mN of thrust at 25.5 Hz.

Future work

To improve lift, rotation and flapping frequency must be predictable and increased. In the next design iteration, a MEMS wing process will be designed to reduce effective mass of the wing frame and ensure precise flexure length. Rigid glass mounting and carbon fiber center beams will improved boundary conditions.

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Figure 12: (a) Average lift force versus frequency of NAV in response to a sinusoidal applied field with amplitude 0.7 V/µm with 0.1 V/µm DC bias and (b) low-pass filtered time signal of lift force at 25.5Hz



Figure 14: Five strobed photographs at different stages of a flapping cycle showing ~30 degrees of passive wing rotation allowed by the flexure hinge, in response to a sinusoidal applied field with amplitude 0.7 V/um with 0.1 V/um DC bias at 9Hz Printing Funded by UPAC



Figure 11: (a) T-beam tip displacement in response to a quasi-static (1Hz) applied electric field (b) measured force of T-beam (left) and corresponding T-beam displacement at the base, due to insufficient clamping



Figure 13: (a) NAV in the closed position (b) NAV in the open position showing ~30 degrees of flapping rotation in response to a sinusoidal applied field with amplitude 0.7 Viµm with 0.1 Viµm DC bias and frequency range from DC to ~9.5Hz

